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Sheet 1 of 1

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE <b>LIST OF ART CITED BY APPLICANT</b> (Use several sheets if necessary)				ATTY. DOCKET NO. M152-1244	SERIAL NO. 09/677,375		
				APPLICANT Black et al.			
				FILING DATE October 2, 2000	GROUP 1765		
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
LV	AA	6,533,053 B1	03/18/03	Alex. III			
	AB	5,368,353	02/09/99	Chen et al.			
	AC	5,365,938	02/09/99	Pecchia et al.			
	AD	5,343,841	12/01/98	Pu et al.			
	AE	5,026,666	06/23/91	Hills et al.			
LV	AF	6,184,327 B1	05/13/02	Grossi et al.			
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AL						Yes
	AM						No
	AN						
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
LV	AR			Stanley Wolf and Richard Tauber. Silicon Processing for the VLSI Era, Vol. 1, pp 549. 1986.			
	AS						
	AT						
EXAMINER LAN VINH				DATE CONSIDERED 3/4/2004			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with 37 CFR 1.96; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							